

L Number	Hits	Search Text	DB	Time stamp
1	8293	roughness near5 surface same (planariz\$5 CMP polish\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/10/23 13:24
2	18	((roughness near5 surface same (planariz\$5 CMP polish\$3)) same relaxed same strained	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/10/23 13:09
3	3	((roughness near5 surface same (planariz\$5 CMP polish\$3)) same relaxed same strained) and @ad<20010619	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/10/23 13:31
4	13	roughness near5 surface with (relaxed strained) with (nanometer? nm)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/10/23 13:30
5	3	(roughness near5 surface with (relaxed strained) with (nanometer? nm)) and @ad<20010619	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/10/23 13:31